

# Microfabricated Low-Loss Microwave Switch Integration Technology, Phase I

Completed Technology Project (2010 - 2010)



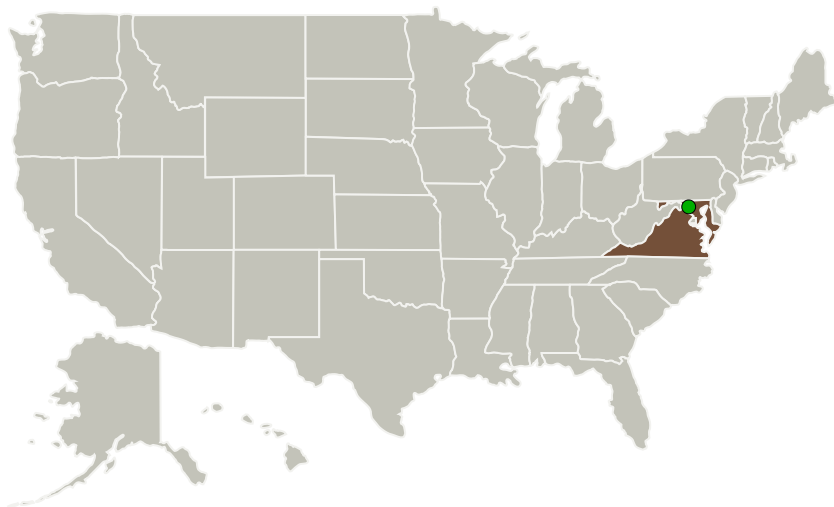
## Project Introduction

Nuvotronics has developed and optimized the PolyStrata

TM

process for the fabrication of intricate microwave and millimeter-wave devices. These devices have primarily been rectangular coaxial transmission lines, although rectangular waveguide and other structures have also been demonstrated. Intricate devices have been demonstrated with insertion loss 5 to 10 times lower than traditional planar circuits; isolation better than 60dB for lines that share separating walls; multiple levels of densely-packed coaxial circuits; and low-parasitic attachment to active devices and traditional circuit boards. In this Phase I project, Nuvotronics will redesign microfabricated MEMs-based switches on the Polystrata platform. Nuvotronics will explore whether piezoelectric-based or magnetic-based actuation provides the best performance for millimeter-wave radiometry applications. The devices will have size and cost advantages, higher power handling capability, and lower loss than achievable with the commonly available wafer-based switches of today.

## Primary U.S. Work Locations and Key Partners



Microfabricated Low-Loss  
Microwave Switch Integration  
Technology, Phase I

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| Organizations Performing Work       | Role                    | Type        | Location            |
|-------------------------------------|-------------------------|-------------|---------------------|
| Nuvotronics, Inc                    | Lead Organization       | Industry    | Radford, Virginia   |
| ● Goddard Space Flight Center(GSFC) | Supporting Organization | NASA Center | Greenbelt, Maryland |

| Primary U.S. Work Locations |          |
|-----------------------------|----------|
| Maryland                    | Virginia |

## Project Transitions

**January 2010:** Project Start

**July 2010:** Closed out

**Closeout Summary:** Microfabricated Low-Loss Microwave Switch Integration Technology, Phase I Project Image

**Closeout Documentation:**

- Final Summary Chart Image(<https://techport.nasa.gov/file/139218>)

## Organizational Responsibility

**Responsible Mission Directorate:**

Space Technology Mission Directorate (STMD)

**Lead Organization:**

Nuvotronics, Inc

**Responsible Program:**

Small Business Innovation Research/Small Business Tech Transfer

## Project Management

**Program Director:**

Jason L Kessler

**Program Manager:**

Carlos Torrez

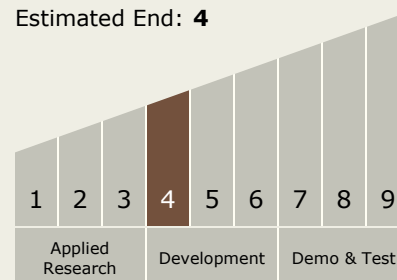
**Principal Investigator:**

Ken Vanhille

## Technology Maturity (TRL)

Current: **4**

Estimated End: **4**



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## Technology Areas

### Primary:

- TX08 Sensors and Instruments
  - └ TX08.1 Remote Sensing Instruments/Sensors
    - └ TX08.1.4 Microwave, Millimeter-, and Submillimeter-Waves

## Target Destinations

The Sun, Earth, The Moon, Mars, Others Inside the Solar System, Outside the Solar System